	Application No.	Applicant(s)
Notice of Allowability	10/080,539	KAGOSHIMA ET AL.
	Examiner	Art Unit
	Karla Moore	1763
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.31	ears on the cover sheet with the co (OR REMAINS) CLOSED in this appl ) or other appropriate communication (IGHTS. This application is subject to	orrespondence address plication. If not included will be mailed in due course. THIS
<ol> <li>This communication is responsive to <u>RCE filed 3/30/04</u>.</li> </ol>		
2. The allowed claim(s) is/are 1-25.		
3. A The drawings filed on 25 February 2002 are accepted by	the Examiner.	
4.  Acknowledgment is made of a claim for foreign priority u a)  All b)  Some* c)  None of the:  1.  Certified copies of the priority documents hav 2.  Certified copies of the priority documents hav 3.  Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)).  * Certified copies not received:    Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  5.  A SUBSTITUTE OATH OR DECLARATION must be subminFORMAL PATENT APPLICATION (PTO-152) which giv 6.  CORRECTED DRAWINGS (as "replacement sheets") mu (a)  including changes required by the Notice of Draftspen 1)  hereto or 2)  to Paper No./Mail Date (b)  including changes required by the attached Examiner' Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in attached Examiner's comment regarding REQUIREMENT	e been received. e been received in Application No cuments have been received in this communication to file a reply MENT of this application.  nitted. Note the attached EXAMINER' es reason(s) why the oath or declara st be submitted. son's Patent Drawing Review ( PTO s Amendment / Comment or in the Comment of the drawing the header according to 37 CFR 1.121(const) of the BIOLOGICAL MATERIAL necessit of BIOLOGICAL materials are supported to the second section of the decession of the decess	national stage application from the complying with the requirements  S AMENDMENT or NOTICE OF tion is deficient.  948) attached  Office action of the back) of all.
Attachment(s)  1.  Notice of References Cited (PTO-892)	5. Notice of Informal P	atent Application (PTO-152)
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summary	(PTO-413),
Information Disclosure Statements (PTO-1449 or PTO/SB/0     Paper No./Mail Date	Paper No./Mail Dat 08), 7.  Examiner's Amendn	
4.   Examiner's Comment Regarding Requirement for Deposit	8.   Examiner's Stateme	nt of Reasons for Allowance

of Biological Material

9. 🗌 Other \_\_\_\_.

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## DETAILED ACTION

## Allowable Subject Matter

- 1. Claims 1-20 are allowed.
- The following is an examiner's statement of reasons for allowance.
- 3. The prior art of record fails to fairly teach or suggest: A semiconductor manufacturing apparatus comprising: an integrated measuring instrument for measuring the form or size of the element to be formed on a wafer; etching means for etching the wafer by using plasma generated under reduced pressure; ashing means for ashing the etched wafer; wetting means for wetting the etched wafer; drying means for drying the wafer which has gone through a wetting treatment; transport means for transporting wafers contained in a wafer cassette one by one successively along a depressurizable transport passage to the integrated measuring instrument and each working unit, including the etching means, the ashing means, the wetting means and the drying means, for treatment; and control means for controlling an order of treatment of each working unit, including the etching means, the ashing means and the drying means for transportation, using said transport means, along a depressurizable transport passage; wherein, depending upon an order of treatment designated by said control means, the etched wafer is ashed and then subjected to the wetting treatment, or the etched wafer is wetted and then subjected to an ashing treatment, and afterwards, the etched wafer is again measured by the integrated measuring means. Further, no other properly combinable piece of art was located to provide the proper motivation for adding the feature(s).

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should

be directed to Karla Moore whose telephone number is 571.272.1440. The examiner can normally be

reached on Monday-Friday, 8:30am-5:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor,

Gregory Mills can be reached on 571.272.1439. The fax phone number for the organization where this

application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application

Information Retrieval (PAIR) system. Status information for published applications may be obtained from

either Private PAIR or Public PAIR. Status information for unpublished applications is available through

Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC)

at 866-217-9197 (toll-free).

km

10 June 2004

P. Harrings M. Parviz Hassanzadeh
Primary Examiner

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